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03500.015730

PATENT APPLICATION

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Re Application of:)
TAKASHI IWAKI ET AL.)
Application No.: 09/941,782)
Filed: August 30, 2001)
For: ELECTRON-EMITTING DEVICE,)
ELECTRON SOURCE AND)
METHOD FOR MANUFACTURING)
IMAGE-FORMING APPARATUS : December 12, 2003

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

INFORMATION DISCLOSURE STATEMENT

Sir:

In compliance with the duty of disclosure under 37 C.F.R. § 1.56, and in accordance with the practice under 37 C.F.R. §§ 1.97 and 1.98, the Examiner's attention is directed the documents listed on the enclosed Form PTO-1449. One copy of each of the listed documents is enclosed, together with a copy of a communication issued by the Korean patent office (and a Japanese translation thereof) in a foreign counterpart application, citing some of the listed documents.

For the concise explanation of relevance for the listed Korean publication, the Examiner is referred to its English-language counterpart U.S. Patent 6,383,047 B1.

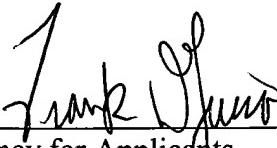
The Examiner also is respectfully referred to the enclosed English translation of Japanese Publication No. 09-106760 and the accompanying English abstract for a concise statement of relevance of non-English document 09-106760.

The listed Chinese document was cited in a First Office Action issued in a counterpart Chinese application. Copies of that First Office Action and an English translation thereof are enclosed. Document 0 986 085, cited in the First Office Action, already is of record, and therefore is not listed on the enclosed Form PTO-1449. An English-language abstract of the Chinese document is submitted herewith. No copy of the Chinese document is presently available.

It is respectfully requested that the above information be considered by the Examiner and that a copy of the enclosed Form PTO-1449 be returned indicating that such information has been considered.

Applicants' undersigned attorney may be reached in our New York office by telephone at (212) 218-2100. All correspondence should continue to be directed to our below listed address.

Respectfully submitted,



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ATTY DOCKET NO.

03500.015730.

APPLICATION NO.

09/941,782

U.S. DEPARTMENT OF COMMERCE
PATENT AND TRADEMARK OFFICELIST OF REFERENCES CITED BY APPLICANT(S)
(Use several sheets if necessary)

APPLICANT

TAKASHI IWAKI ET AL.

FILING DATE

AUGUST 30, 2001

GROUP

2875

Date Submitted to PTO:[DATE]



U.S. PATENT DOCUMENTS

*EXAMINER INITIAL	DOCUMENT NUMBER	DATE	NAME	CLASS	SUBCLASS	FILING DATE IF APPROPRIATE
	6,383,047 B1	05/07/02	Minami et al.	445	6	09/02/99

FOREIGN PATENT DOCUMENTS

	DOCUMENT NUMBER	DATE	COUNTRY	CLASS	SUBCLASS	TRANSLATION YES/NO/ OR ABSTRACT
	9-106760	04/22/97	Japan	H01J	9/02	Abst. & Trans.
	2000-0022939	04/25/00	Korea			Abst. & counterpart U.S. Patent 6,383,047
	1043506A	07/04/90	China	C08F	2/48	Abst.

OTHER DOCUMENT(S) (Including Author, Title, Date, Pertinent Pages, Etc.)

EXAMINER

DATE CONSIDERED

*EXAMINER: Initial if reference considered, whether or not citation is in conformance with MPEP 609; Draw line through citation if not in conformance and not considered.
Include copy of this form with next communication to applicant.